

(19)



Europäisches Patentamt  
European Patent Office  
Office européen des brevets

(11) Publication number:

**0 177 809**  
**A1**

(12)

# EUROPEAN PATENT APPLICATION

(21) Application number: 85111749.9

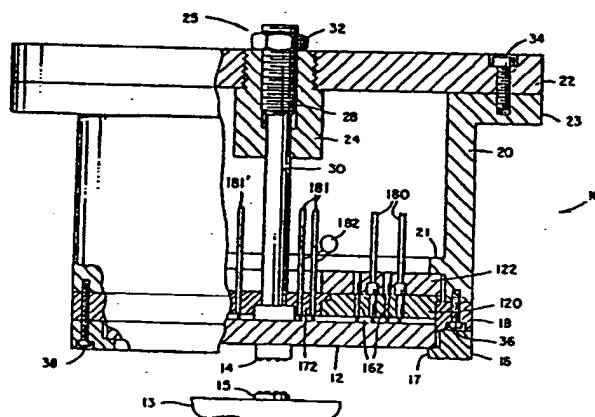
(51) Int. Cl.: **G 01 R 1/073, H 01 R 17/12**

(22) Date of filing: 17.09.85

(30) Priority: 21.09.84 US 652985

(43) Date of publication of application: 16.04.86  
Bulletin 86/16(84) Designated Contracting States: **DE FR GB**(71) Applicant: **International Business Machines Corporation,**  
Old Orchard Road, Armonk, N.Y. 10504 (US)(72) Inventor: **McAllister, Michael Ford,** Maple Avenue,  
Clintondale N.Y. 12515 (US)  
Inventor: **Mack, Alfred,** 79 Lauer Road R.D. 2,  
Poughkeepsie N.Y. 12603 (US)(74) Representative: **Teufel, Fritz, Dipl.-Phys. et al, IBM**  
**Deutschland GmbH, Europäische Patentdienste**  
Postfach 265, D-8000 München 22 (DE)(54) **Coaxial connector arrangement.**

(57) An arrangement for interconnecting coaxial cables to a device (12), such as a testing apparatus for an integrated circuit chip, includes an apertured plate (120) of electrically conducting material which allows to position one or more connectors (180) in registration with corresponding terminals of the device. Each connector includes a spring-loaded probe insulated from a housing (128) of the connector and making connection between an inner conductor of a coaxial cable and the corresponding terminal of the device. Also included may be signal-return spring-loaded probes (162) mounted in the plate (120) and electrically connected thereby to the outer conductors of the coaxial cables to provide signal-return paths with corresponding terminals of the device. Using two such connectors, a pair of cables can be joined.



**EP 0 177 809 A1**

COAXIAL CONNECTOR ARRANGEMENT

This invention relates to a coaxial connector arrangement in accordance with the preamble of claim 1.

Coaxial cables are widely used in the transmission of electric signals. Such cables have an inner conductor disposed along the axis of the cable, and an outer conductor disposed circumferentially about the inner conductor in the manner of a shield or sleeve. The inner and outer conductors are spaced apart by a coaxial layer of insulating material of suitable dielectric characteristics for establishing a desired impedance to the cable. Such cables are manufactured in a large variety of sizes including both large and smaller diameters. Connectors at the termini of the cables maintain the coaxial configuration in the arrangement of the connector components. The connectors are usually structured as male and female counterparts and include a locking device, such as a spatial groove and tooth, for secure engagement of connectors to each other.

There is particular interest in the use of coaxial cables in the testing of semiconductor microcircuits. In a complex circuit, there may be

many terminals which are to be connected to testing apparatus and, accordingly, many cables are to be employed in the connection of the semiconductor microcircuit to the testing apparatus. In the case of the testing of microcircuits formed as chips with electrodes in the form of pads, the sizes of the pads and their spacing are too small to connect with even the smallest sizes of coaxial cable. Accordingly, devices have been constructed which interface between a set of pads and coaxial cable connectors.

A problem attendant the use of such interfacing devices is the compromise between bandwidth and the physical size of the device necessary to accommodate standard coaxial connectors. Thus, the physical size of presently available coaxial connectors places restraints on the construction of the interfacing device. This may be readily appreciated because the interfacing device essentially transforms the spatial array of the microcircuit pads to the spatial array of the coaxial connectors.

Even if the pads of the microcircuit were enlarged, no direct connection could be made between the connector and the pad because presently available connectors are not configured for mating with a flat surface.

It is therefore the object of the present invention to provide a coaxial connector arrangement that allows to access one or a plurality of small contact pads, e.g. of microcircuit devices, is easy to use and manufacture and has excellent electrical properties.

This object is achieved by the invention as described in claim 1; embodiments of the invention are characterized in the dependant claims.

The coaxial connector arrangement in accordance with the invention comprises a spring-loaded pin-shaped contact disposed in the center of the connector and an enlarged circumferential conducting element which is isolated from and surrounds the central contact. The central contact connects with the inner conductor of a coaxial cable, and the circumferential element connects with outer conductor of the coaxial cable. The circumferential element serves as a housing for one or more outer contacts which are spring loaded and pin shaped, the outer contacts being electrically connected to the outer conductor of the coaxial cable via the circumferential element. The spring loading provides resiliency which permits the contacts to retract into the connector

via movements parallel to the axis of the connector.

The foregoing connector arrangement permits contact to be made with a flat array of  
5 opposed contacts without the need for any manual  
twisting of the connector to secure a connection.  
There is a resultant substantial savings in space  
which permits increased freedom in the design of  
one of the foregoing interface devices.

10 A group of the connectors can be ganged  
together and held in position by a common plate  
having apertures for engagement with the  
connectors, and by which the respective cables  
have access to the connectors; hand-held  
15 arrangements can be used as probes to test  
electrical circuits.

Two connectors can be coupled with the  
aid of a sleeve that encompasses and positions the  
two connectors to join two coaxial cables without  
20 the necessity for manufacturing male and female  
types of connectors.

Embodiments of the invention are  
explained in the following description taken in  
connection with the accompanying drawings, wherein  
25 like reference numerals indicate like parts  
throughout the figures, and wherein:

Figure 1 is a partially sectioned side  
view of an interface device including a space

transformer useful in the testing of an integrated microcircuit, the design of the space transformer serving as an example of a situation wherein a set of the coaxial connectors of the invention can be used to great advantage in the testing of semiconductor integrated circuits;

Figure 2 is a detailed sectional side view of a portion of the space transformer and a rigid probe of the interface device of Figure 1;

Figure 3 is a detailed sectional side view of a coaxial connector incorporating the invention and connecting a coaxial cable to the interface device of Figure 1;

Figure 4 shows a sectional side view of a single coaxial connector of the invention connecting with pads of an integrated circuit chip carrier;

Figure 5 shows an embodiment of the coaxial connector in accordance with the invention wherein the connector is configured as a probe; and

Figure 6 shows an embodiment of the invention wherein two connectors are coupled together by a sleeve.

The following description of preferred embodiments of the invention has two parts. First an interface device which advantageously

employs the connectors of the invention will be described with reference to Figures 1 and 2. Then the remaining figures will be used for describing embodiments of the connector, the embodiment of Figure 3 being particularly useful for the interface device. The interface device is presented in Figures 1 and 2 as a test fixture structure 10.

With reference to Figures 1 and 2, the test fixture structure 10 comprises a space transformer 12 with a probe assembly 14 depending therefrom for contacting terminal pads of an integrated circuit 15 positioned for testing on a holder shown, by way of example, as a flat 13. The structure 10, the transformer 12 and the probe 14 are provided each with square (or rectangular) form, the size of the probe 14 being much smaller than that of the transformer 12 so as to interface with the integrated circuit 15.

The structure 10 further comprises square connector plate 120, signal connector retainer plate 122, central connector plate 172, sidewall 20, and space transformer cap 16 and positioning nest 18. A detailed description of the construction and function

of the space transformer 12 and rigid test probe 14 is provided in the European patent application 85111439.7, which is accordingly

expressly incorporated herein by reference.

5  
10  
15  
20  
Considering the structure 10 now in greater detail, the square connector plate 120 is preferably of highly conductive metal, such as gold-plated brass, that is electrically connected to a ground reference potential. Openings provided essentially perpendicularly through the square connector plate 120 provide electrical connection with and position signal connectors 180 and ground connectors 162 therein. The connectors 162, 180 are described in greater detail with respect to Figure 3 below. However, it is sufficient now to note that they are of a movable spring-loaded type of construction providing a center conductor that is compressively spring loaded. Thus, the conductive interface between the connectors 162, 180 and the connector plate 120 serves to provide the shortest, least resistive ground connection path to the connectors 162, 180. The connectors 162 preferably are press fit within openings of the plate 120 to ensure



their proper retention in the square connector plate 120.

5           Power connectors 181 are similarly press fitted into openings extending essentially perpendicularly through the central connector plate 172. The central connector plate 172 significantly differs from the square connector plate 120 in that it is formed preferably of an excellent dielectric material having significant structural strength, such as AF DELRIN. Thus, the design and construction of the power connectors 181 is simplified, since no additional insulator is required. The central connector plate 172 is generally square shaped and preferably dimensioned to fit within a central opening of the square connector plate 120 and around a central brace 30 substantially as shown in Figure 1. The power connectors 181 are not integrally shielded and, accordingly, decoupling capacitors 182 may be connected easily with sufficiently short connection leads to avoid the introduction of undesirable parasitic inductances.

15           The signal connector retainer plate 122 sets upon the connector plate 120 and overlaps a portion of

the connector plate 172 for retaining these plates in their respective positions. Retainer plate 122 is constructed preferably of a dielectric material such as AF DELRIN having sufficient structural strength to retain the central and square connector plates 120, 172.

Holes 124, 126 (best shown in Figure 3) are preferably provided essentially perpendicularly through the retainer plate 122 to allow wire leads to pass therethrough as necessary to reach the signal connector 180 and provide body clearance for ground connector 162. These openings for signal connector 180 are preferably counterbored to fit over flanges provided on the connector outer surfaces. These flanges, as will be described in greater detail below with regard to Figure 3, not only act to establish the depth that the connector 180 may be press fitted into the square connector plate 120, but also permit the connector retainer plate 122 to provide as strain relief for the connector lead wires. Openings may also be provided in the signal connector retainer plate 122 as necessary to allow the upper portion of the ground connectors 162

to extend unobstructed above the square connector plate 120.

5 The sidewall 20, constructed preferably of a light weight structural aluminum alloy, includes a flange 23 for attachment by several screws 34 to a support bridge 22. A screw assembly 25 comprises an internally threaded insert 24, a screw 28 mating therewith, and a locking nut 32, the assembly being provided at the center of the bridge 22 to apply pressure adjustably to the brace 30. A flange 21 is provided on the inner surface of the sidewall 20 and extends sufficiently inward to contact the upper edge surface of the plate 122, substantially as shown in Figure 1. The transformer positioning nest 18 is attached to the bottom end of the sidewall 20 by several counterborescrews 36, and extends inwardly of the sidewall 20 to contact a bottom edge portion of the square connector plate 120 to secure the positioning of the retainer 122. The transformer cap 16 is formed of a set of retainer segments which, in turn, are attached through the positioner 18 to the sidewall 20 by several counterbored screws 38.

Each of the retainer segments of the cap 16 is provided with a flange 17 that extends inwardly to engage a bottom edge portion of the space transformer 12, substantially as shown. The dimensions of the cap 16 are preferably appropriate to secure the space transformer 12 with respect to the connector plates 120, 172 such that the upper surface of the space transformer is uniformly positioned along the bottom surface of the connector plates 120, 172.

In moving the space transformer 12 into close proximity with the connector plates 120, 172, the spring loaded central conductors of the various connectors are compressed into the bodies of their respective connectors, each preferably with a resistive force of approximately 10 grams initially and 20 grams ultimately, as will be described hereinafter with reference to Figure 3. The gap between the space transformer 12 and the connector plates 120, 172 is preferably as small as practically possible to minimize the unshielded length of the center conductors of the signal probes 180 as they extend across the gap. This is desired to correspondingly reduce the degree of

electrical discontinuity caused by the unshielded condition, as will be discussed in greater detail below.

5 Although not shown, the brace 30, square plates 120, and spacer nest 18 are preferably provided with interlocking dowels. By the proper selection of the placement of the dowels, the correct orientation of the connectors 162, 180, 181 can be insured effectively so as to properly contact electrodes on the top surface of the space transformer 12.

10 For purposes of completeness, a representative detail portion of the preferred space transformer 12 and probe assembly 14 is shown in Figure 2. The structure of the space transformer 12 is set forth in the aforementioned copending <sup>European</sup> patent application. Structural features thereof are repeated here so as to demonstrate the continuity of signal flow structure from the connectors 180, 162, 181 to the probe assembly 14. Thereby it can be appreciated that the structure of the connectors 180, 162, 181 allows broadband electromagnetic signal propagation to and from the space transformer 12 with minimal impedance

mismatch.

The space transformer 12 is a multilayer ceramic (MLC) design fabricated using conventional ceramic layer laminate technology. The structure so  
5 formed preferably includes a minimum of three planar ceramic layers 40, 42, 44 separated by two highly conductive material layers 46, 48, preferably of a metal or metal alloy having a coefficient of expansion similar to that of the specific ceramic used. The  
10 first conductive layer 46 is preferably used as a power plane and the second as a power return or ground plane 48 for reasons that will be discussed in greater detail below.

A via provided in the layer 40 allows a  
15 conductive bus 52, preferably of a metal such as molybdenum, to extend between the layer 46, this being a power plane, and an electrode 62, preferably of gold or equivalent highly conductive, oxidation resistant  
20 metal or alloy, provided on the ceramic layer 40 external surface that will ultimately become the top surface of the space transformer 12. Similarly, a conductive bus 54 extends between the layer 48, this

being a ground plane, and a surface electrode 64 through vias in the two interposed ceramic layers 40, 42 as well as through an appropriate opening in the power plane 46 needed to prevent shorting.

5           A desired plurality of signal buses 56 (only one is shown) are provided to conduct signals from electrodes 66 (only one electrode 66 shown in Fig. 2) present on the top surface of the space transformer 12 to one of many electrical conductors 50 formed as  
10       ) metallic film on the bottom surface of the transformer 12. The conductors 50 are spaced apart from the bottom surface of the ceramic layer 44 by another electrically-conductive metallic layer 51 and an  
15       electrically-insulating layer 53, the layer 53 being sandwiched between the conductors 50, and the layer 51, the latter contacting the ceramic layer 44. The buses 56 extend through respective vias in the ceramic layers 40, 42, 44 and openings in the power and ground planes  
20       (layers 46 and 48) as well as layers 51 and 53. Conventional thin film deposition techniques are used to provide the layer 51, which layer serves as a high frequency (greater than 50MHz) AC ground reference

5 layer overlying substantially all of the bottom surface of the space transformer 12. The thin film conductors 50 which are conductively coupled to respective signal buses 56 are patterned on the layer 53 as necessary to spatially interconnect to the signal conducting wires 102 of the probe assembly 14 described in greater detail below.

10 The probe assembly 14 generally includes a rigid structural body 100 of a conductive metal maintained at the ground reference potential. Also included are signal probes 102, each having a central conductor wire separated from the grounded body 100 by a dielectric coating to establish a coaxial signal line having a desired impedance (preferably 50 ohms), ground probes 104 that are intimately grounded to the body 15 100, and power probes 106 having a thin, insulating oxide layer covering a low impedance center conductor.

20 As shown, the signal probe 102, ground probe 104, and power probe 106 extend through the body 100 sufficiently for their distal probe points to appropriately contact respective signal, ground, and



power native pads (typically C-4 solder bumps, not shown) of the integrated circuit 15. The proximal ends of the probes 102, 104, 106 are conductively connected to their respective planes of the conductors 50, the layer 48 and the layer 46 of the space transformer 12. That is, the power probe 106 conductively abuts a bus 90 extending from the power plane 46 to the bottom surface of the space transformer 12 through vias in the lower two ceramic layers 42, 44 and openings in the ground and wiring planes of elements 48, 51, 53 and 50. Similarly, a bus 92 conductively extends from the ground plane of layer 48 to the bottom surface of the space transformer 12 through a via in the bottom ceramic layer 44 and an opening in the planes of elements 50, 51 and 53 as necessary to connect to the ground probe 104. The signal probes 102 conductively connect, as an array thereof, directly to the set of conductors 50 by contacting the exposed surface of their respective thin film conductors 50.

5 The preferred structure of the space  
transformer 12 is essentially completed by the  
provision of low connection inductance, high-frequency  
decoupling capacitors 74, 84 extending between the  
planes of the power layer 46 and ground layer 48.  
The capacitors 74, 84 are preferably of a thin film  
construction and spatially positioned as desired on the  
top and bottom external surfaces of the space  
transformer 12. Connection of the capacitors 74, 84 is  
10 made to the power layer 46 and ground layer 48 by  
respective power 70, 80 and ground 72, 82 buses  
extending through vias in the ceramic layers 40, 42, 44  
and corresponding openings in the power and ground  
layers 46, 48. The short length of connection between  
15 the capacitors 74, 84 and the power and ground layers  
46, 48 and the use of a low inductance bus metal, such  
as molybdenum, results in minimum connection  
inductance. Naturally, the high-frequency behavior of  
the capacitors 74, 84 depends on the dimensions of the  
20 capacitor electrodes and dielectric parameters of the  
capacitor insulator material. The use of thin film  
capacitors attached to the surfaces of the space

transformer 12 and connected by integral buses allows the capacitors to be placed at any convenient point and contributes to the realization of a unitary, easily manipulated structure.

5                   The structure of the space transformer 12  
constructed in accordance with the present invention  
significantly provides for an arrangement of the layers  
46, 48, 51 and conductors 50 which may be regarded as a  
mesh plane array. The ground planes of layers 48, 51  
10                   interposed between the power plane of layer 46 and the  
thin film conductors 50, effectively shields the power  
plane and thin film conductors from one another. With  
respect to the power plane of layer 46, the provision  
of the low connection inductance decoupling capacitors  
15                   stabilizes the high-frequency power voltage potential  
without significantly contributing to the generation of  
current noise ( $dI/dt$ ). With respect to the thin film  
conductors 50, the provision of the reference ground  
plane of layer 51 further isolates and, by the proper  
20                   selection of the dimensions of the thin film conductors  
50 and the thickness of layer 53 according to standard  
transmission line theory, permits the characteristic

impedance of the conductors 50 to be maintained at an optimal value, preferably fifty ohms. Thus, the impedance of the signal conductors 50 can be independently established at a value much higher than that of the power and ground planes (generally less than 1 ohm, and preferably less than 0.5 to 0.1 ohms).

Again referring to Figure 1, the test structure 10 in operation positions the space transformer 12 with the attached probe assembly 14 in close proximity with the integrated circuit 15. As should be readily apparent to persons skilled in the art, the circuit 15 is preferably provided in its initial or native package and mounted in a suitable holder, here simply represented by the flat 13, so as to present and make accessible the array of native conductive pads of the circuit 15 to the rigid test probe 14 in a plane preferably parallel to the flat 13. The probe wires are preferably arrayed parallel to one another so as to orthogonally match the corresponding array, or footprint, of native contact pads of the integrated circuit 15. Correspondingly, the number of probe wires is preferably equal to or less than the

number of native pads as necessary to provide power and test signals to the integrated circuit 15 and receive return signals therefrom. The space transformer 12 is then advanced toward the flat 13 until the tips of the probe wires encounter the pads of the integrated circuit with sufficient pressure to ensure proper electrical contact therebetween.

The brace 30, abutting the top surface of the space transformer 12 opposite the probe assembly 14, is effectively utilized to prevent the space transformer 12 from flexing as pressure is applied thereto by the sidewall 20. Naturally, the initially nominally flexed position of the space transformer 12 is set and subsequently maintained by adjustment of the screw assembly 25. After testing, the test structure 10 is backed off and the integrated circuit 15 can be removed undamaged.

Referring now to Figure 3, there is shown a greatly expanded sectional view of one of the signal connectors 180 and an adjacent ground connector 162 in contact with their respective space transformer electrodes 66, 64, previously shown in Figure 1.

Central to the signal connector 180 is a spring-loaded probe 134 which is a modification of a probe marketed under the name of "POGO PROBE," with part number P-2784-3 by the PYLON Company of Attleboro, Massachusetts, the modification being accomplished by fabricating the probe of non-inductive materials, such as berrilium copper, and reducing spring contacting force. The probe 134 has a body 135 which is a thin wall, conductive metal tube housing a center conductor or pin 136, metal stopper ball 138, and compression spring 140. A press fit insulator insert 132, preferably of Teflon<sup>TM</sup>, is provided coaxially about and extending the length of the probe 134. The insulator insert 132 is, in turn, press fitted into a body tube 128 of the connector 180, the tube 128 being constructed of a highly conductive metal, preferably gold plated brass, that forms the supporting shell of the signal connector 180. The body tube 128 preferably has a thin wall lower portion 129, a relatively thicker walled flange portion 130, and a thin walled upper portion 131, substantially as shown in Figure 3.

The external dimensions of the lower portion

129 of the body tube 128 are selected preferably, to allow the secure press fitting of the lower portion into the hole 127 provided in the connector plate 120. As noted above, the flange portion 130 is of a relatively greater outer diameter forming a shoulder which establishes the depth that the end of the lower body tube portion 129 is inserted into the connector plate 120; i.e., preferably so as to be substantially flush with the bottom surface of the connector plate 120.

A small-diameter coaxial cable 183 such as the commercially available microdot<sup>TM</sup> cable is preferably used as the test lead attached to the probe 134 of the signal connector 180. The cable 183 generally includes a core 144 comprising a central signal line conductor 142 within a dielectric sheath 143, and a coaxial ground shield 146 enclosing the core 144. Connection to the probe 134 is accomplished by soldering or otherwise suitably attaching the extended end of the signal line conductor 142 into the hole in the upper terminus of the probe 134. The stopper ball 138 is an integral part of probe 134. The lower end

of the dielectric sheath 143 is separated from the ground shield 146 and is inserted into the upper portion 131 of the body tube 128 so as to abut the top end of the probe 134. A washer of a dielectric material 155, directly beneath the sheath 143, closes off the top of the probe 134 and contacts the insulator insert 132. The ground shield 146 of the cable 183 is expanded around and extended the length of the upper body tube portion 131 and, therefore, is in conductive contact therewith. Consequentially, the ground shield 146 is effectively extended the full length of the probe 134 while the insulator insert 132 serves to electrically isolate the signal probe 134 from the grounded body tube 128 as well as to maintain the desired signal line impedance. The appropriate material of the insulator insert 132 and necessary radial thickness are selected in a well-known manner to obtain the desired signal line impedance.

A connector sleeve 150 is provided to essentially complete the signal connector 180. The sleeve 150, preferably of a conductive metal, is press fitted over that portion of the ground shield 146 of



the cable 183 expanded over the upper tube portion 131 of the body tube 128. Thus, the attachment of the cable 183 to the body tube 128 is effectively secured so as to form an integral signal connector 180, substantially as shown in Figure 3.

Finally, a shrink fit insulative coating 152 may be provided over the cable 183 and a portion of the sleeve 150 to substantially seal the connection of the cable 183 to the body tube 128 from deleterious environmental effects, such as corrosion.

As previously noted, the signal connector retainer plate 122 is provided with a counterbored hole 124 to receive the upper portion of the signal connector 180 and allow the test lead attached thereto to pass through. The counterbored portion of the hole 124 is specifically dimensioned to receive only the flange portion 130 of the body tube 128. Since the diameter of the remaining portion of the hole 124 is preferably less than that of the flange portion 130, the signal connector retainer plate 122 inherently functions as a strain relief.

The ground connector 162 is of essentially

identical construction to the probe 134 of the signal connector 180. However, the ground probe 162 significantly differs in that it is press fitted directly into a hole 164 provided therefor in the connector plate 120. A terminal pin 160 of the ground connector 162 is, therefore, intimately conductively coupled to the ground reference potential of the connector plate 120 and no further electrical connection need be made to the ground connector 162. Consequently, the present invention obviates the added complexity, materials and consumption of working space, as would be required to provide separate ground connector leads. Also, any number of ground connectors 162 may be provided and positioned as desired without significantly increasing the complexity of the fixture 10. As previously noted, holes 126 may be provided in the signal connector retainer plate 122 to accommodate any portion of the ground connectors 162 that extend above the connector plate 120.

The power connectors 181 (shown in Figure 1 but not shown in Figure 3) are of construction generally similar to that of the signal connectors 180.

However, the need for an insulator insert analogous to insert 132 is obviated by the fact that the central connector plate 172 (Figure 1) is itself an insulator. Thus, the probe of the power connector 181 is preferably press fitted directly into an appropriately dimensioned body tube analogous to the signal body tube 128. The absence of a power conductor shield, however, allows the simple connection of the decoupling capacitors 182 (Figure 1) without risk of creating an electrical discontinuity by a breach of a ground shield. Also, the need for lengthy conductors connecting the capacitors 182 to the power connectors 181 is eliminated with the corresponding reduction of parasitic inductances introduced by the connection of the capacitors 182.

Thus, a high speed integrated circuit test fixture utilizing a coaxial connector interface to a space transformer and, thereby, realizing signal paths that are essentially free of electrical discontinuities has been described.

In the foregoing description of the structure 10, there is provided a two-dimensional array of

connectors 180 interleaved with a two-dimensional array of connectors 162 contacting the upper surface of the transformer 12. Since all of the ground connectors 162 contact the connector plate 120, the return current for a signal in any one of the signal connectors 180 can pass through a plurality of the ground connectors 162. In this way it is possible for a ground return current to be uniformly distributed about the pin 136 of a signal connector 180, thereby reducing any effects of inductance and stray radiation which may be present. The benefits of the symmetry of ground return paths can also be provided in an embodiment of the invention wherein only one signal carrying probe 134 is present, as is shown in the embodiment of Figure 4.

With reference now to Figure 4, there is shown an embodiment of the invention wherein a connector 200 comprising three probes 134, of which individual ones thereof may be further identified by the legends A, B and C when it is desired to refer to a specific one of the probes 134A-C, abuts a circuit chip carrier 202 to permit measurement of signal parameters thereof. In the use of the connector 200, the

connector 200 is manually brought into contact with the chip carrier 202 such that individual pins 136 of the probes 134 contact respective ones of a set of terminal pads 204 of the chip carrier 202. Individual ones of the pins 136 and the pads 204 may be further identified by the legends A, B and C when it is desired to refer to individual ones of these elements. The connector 200 also comprises further ones of the elements previously seen in Figure 3, namely, the sleeve 150 for holding down the shield 146 of the cable 183, the insulator insert 132 enclosing the probe 134A, and the washer 155 located between the insert 132 and the sheath 143 of the cable 183. The line conductor 142 of the cable 183 is connected by solder at 206 to the probe 134A.

The connector 200 is constructed of a housing 208 having a crown 210 at one end of the housing 208 defining a shoulder 212. The housing 208 is formed of an electrically conducting metal such as that employed in the body tube 128 of Figure 3. Three bores 214 A - B and C are provided within the housing 208 and extend from the crown 210 to the opposite end of the housing

208. A further bore 216 communicates with the bore 214A and extends away from the bore 214A along the axis thereof through the crown 210 and through a cylindrical extension 218 of the crown 210. The probe 134A with its insulator insert 132 and washer 155 set within the bore 214A, and the probes 134B-C set within the bores 214B-C respectively. The core 144 of the cable 183 sets within the extension 218, and the shield 146 of the cable 183 is separated from the core 144 at the extension 218 to be clamped between the outer surface of the extension 218 and the inner surface of the sleeve 150.

Upon comparing the embodiments of Figures 3-4, it is noted the probes 134B-C of Figure 4 provide the ground return current paths as do the ground connectors 162 of Figure 3. While only two such ground return paths are shown in Figure 4, additional probes 134 may be mounted in electrical contact with the housing 208 along a plane perpendicular to the plane of the probes 134B-C so as to provide axial symmetry to the flow of the ground return current about the central probe 134A. Thereby, the connector 200 provides the

functions of the signal connector 120 of Figure 3 in combination with a plurality of the ground connectors 162, all within a single housing which is positioned readily and manually upon the circuit chip carrier 202.

5

In Figure 5, there is shown a connector 200A which is a modification of the connector 200 of Figure 4. One side of the connector 200A is extended to form a handle 220 to facilitate a manual grasping of the connector 200A. The connector 200A is formed of an electrically conducting metal and includes the probe 134A mounted within a housing 208A and insulated therefrom by the insert 132 for carrying electric signals from the cable 183. Also included is the probe 134C in electrical contact with the housing 208A of the connector 200A to provide the ground return path for the electric current flowing in the cable 183. While the connector 200A does not provide the symmetry of ground return, it enjoys a simplicity of structure over that of the connector 200, and is employed manually in the same manner as the connector 200.

10

15

)

20

Figure 6 shows a connector 200B which is a further modification of the connector 200 of Figure 4.

In Figure 6, two of the connectors 200B are connected together by a sleeve 222, thereby to join two of the cables 183. Each of the connectors 200B comprises a housing 208B of generally cylindrical form which includes the bores 214A and 216 shown above in Figure 4. The bore 214A houses the insulator insert 132, the probe 134A and the washer 155, while the bore 216 houses the core 144 of the cable 183 as was disclosed in Figure 4. The outer surface of each housing 208B is configured with a shoulder 224 which abuts an end of the sleeve 222 upon insertion of the connectors 200B; into opposite ends of the sleeve 222. The connectors 200B are inserted a sufficient distance for contacting opposed pins 136A of the probes 134A. The housings 208B and the sleeve 222 are fabricated of metal to provide electrical conduction between the shields 146 of the respective cables 183. The contacting of the pins 136A provides for electrical connection of the inner conductors 142 of the respective cables 183. The ground connectors 162 of the previous embodiments are not required in the embodiment of Figure 6 because adequate secure electrical connection is provided by



contact between the sleeve 222 and each of the connectors 200B. The embodiment of Figure 6 represents a particularly useful and simple interconnection of two coaxial cables.

C L A I M S

1. Arrangement to connect at least one coaxial cable (183) to electrical contacts on a device (12), characterized in that a plate (120) with an electrically conducting surface is provided, the plate having one aperture (124) for each of the coaxial cables to receive, in electrically isolated mounting, a first electrically conducting probe (180) with a resilient pin (136), wherein the inner (142) and the outer (146) conductors of each coaxial cable are electrically connected to the pin of the associated probe and the plate, resp.
2. Arrangement according to claim 1, characterized in that the probe includes a spring (140) to provide resilience to the pin.
3. Arrangement in accordance with claim 1 or 2, characterized in that the plate contains a single aperture and is outwardly configured to mate with a cylindrical sleeve (222) to permit an interconnection to a second coaxial cable having an identical single-aperture plate.

4. Arrangement in accordance with claim 1 or 2, characterized in that the plate contains at least one further aperture (126), each further aperture receiving a second electrically conducting probe (162) including a resilient pin in electrically conductive relationship with the plate (120), the first and second probes being arranged to register with a flat pattern of electrical contacts on the device (12).
5. Arrangement in accordance with claim 4, characterized in that one first and one second probe is provided and that the plate (208A) comprises an extension (220) to be used as a handle.
6. Arrangement in accordance with claim 4, characterized in that the second probes are arranged symmetrically around each first probe.
7. Arrangement in accordance with claims 4 and 6, characterized in that the first and second probes are press-fit into the apertures of the plate and that on top of the plate a retainer (122) is provided to retain the probes by exerting a pressure on a flange portion (130) of the probes protruding above the plate (120).
8. Arrangement in accordance with claims 4, 6 and 7, characterized in that the plate (120) comprises an insert (172) of an electrically non-conducting material having apertures to receive third electrically

conducting probes (181) with resilient probes to supply power to the device to be contacted.

9. Arrangement in accordance with claim 8, characterized in that decoupling capacitors (182) are connected to the third probes.
10. Arrangement in accordance with one of the claims 4 and 6 to 9, characterized in that the plate (120) is brought in close proximity to a planar space transformer circuit (12) providing on its one surface a contact pattern for the first, second, and third probes and on its other surface a contact pattern to match contact pads on a microcircuit (15).

FIG. 1.

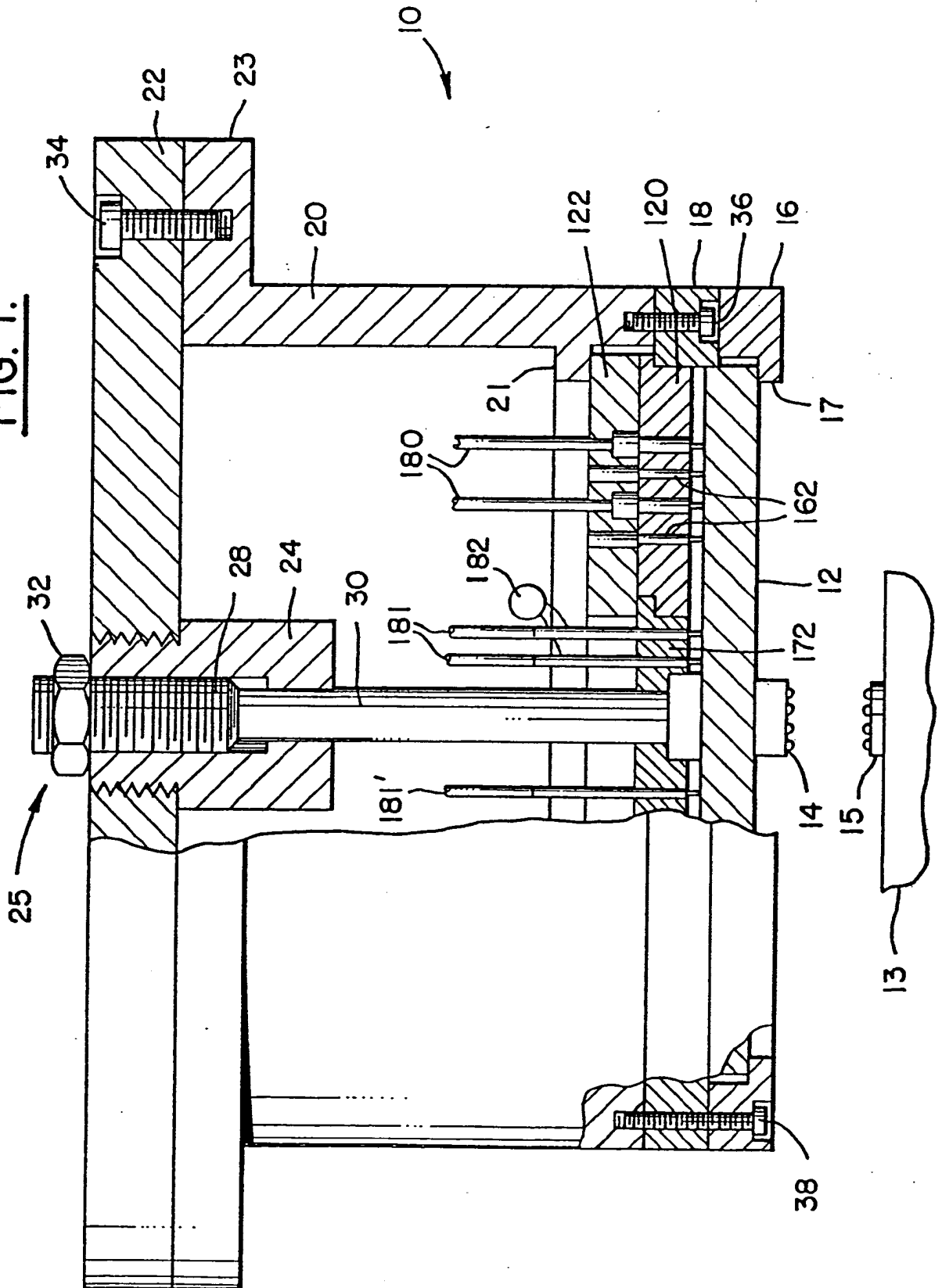


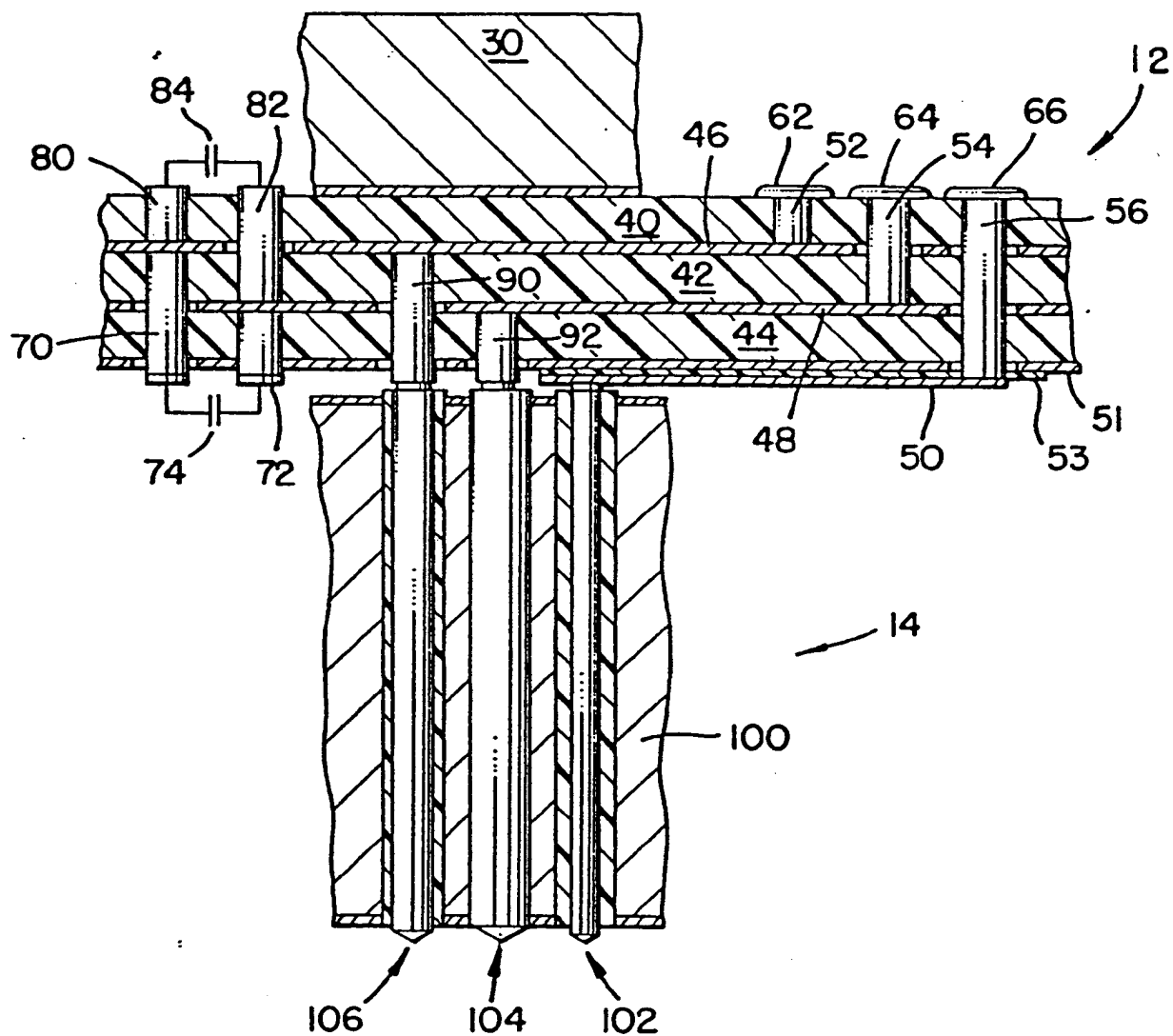
FIG. 2.

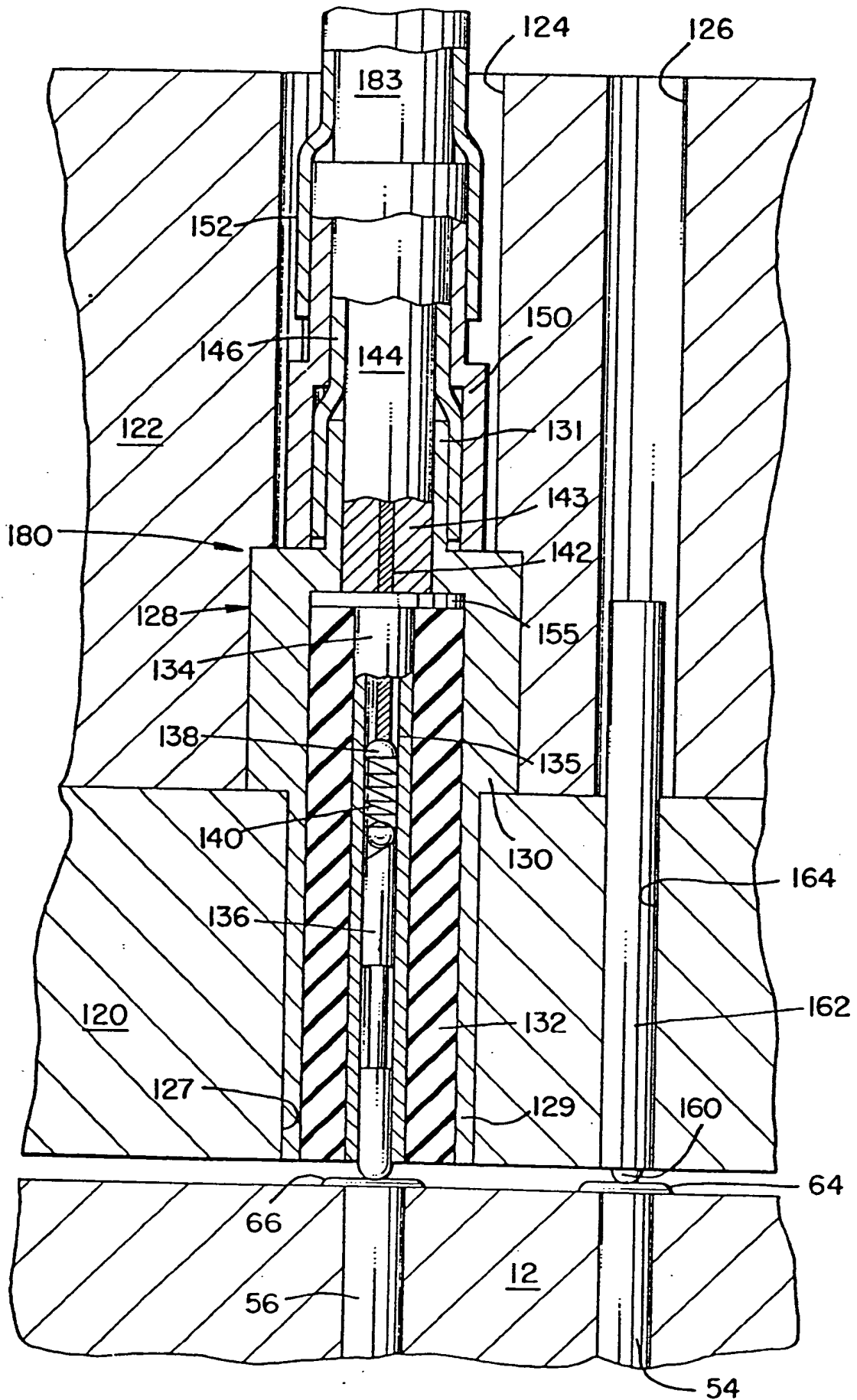
FIG. 3.

FIG. 4.

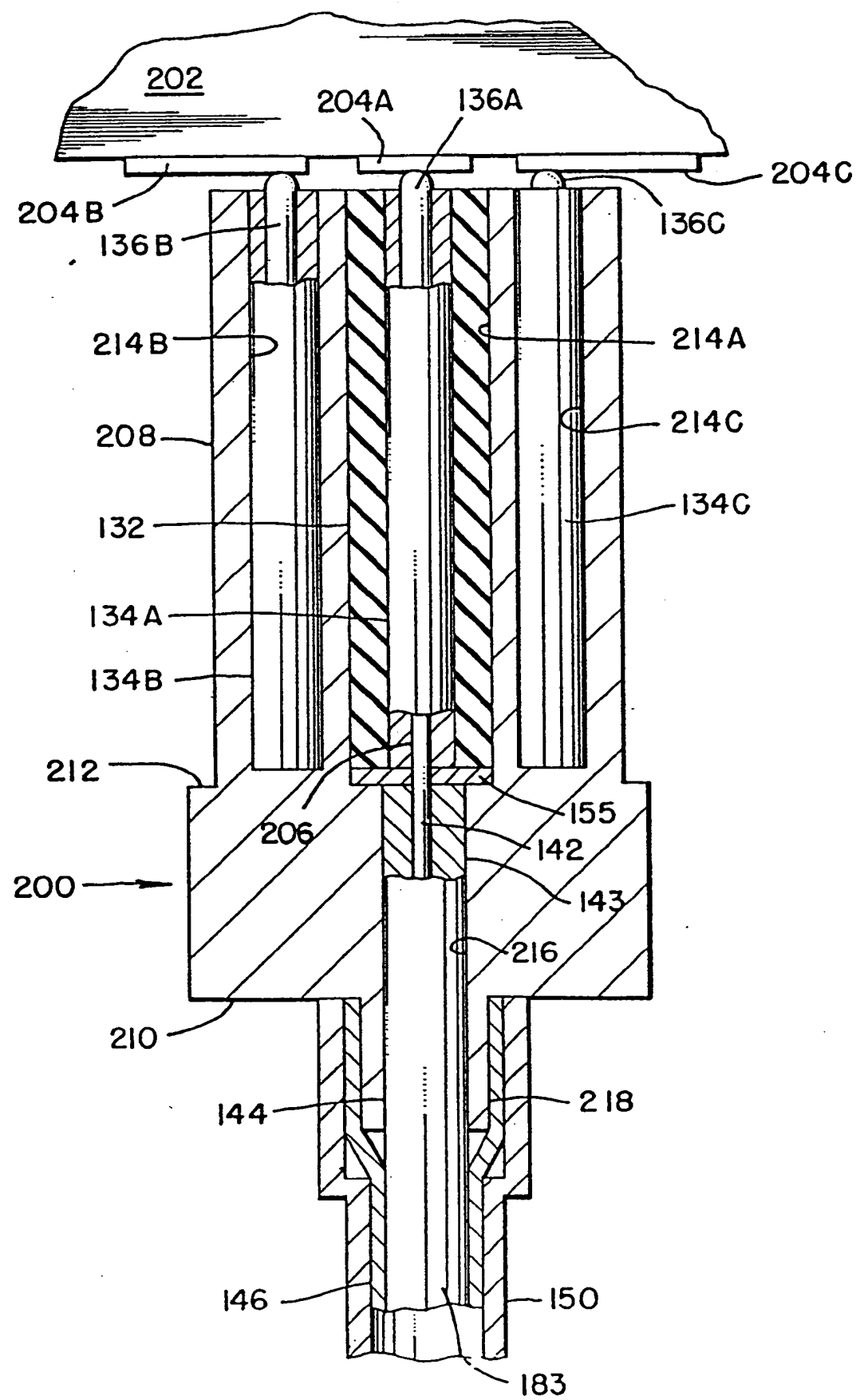




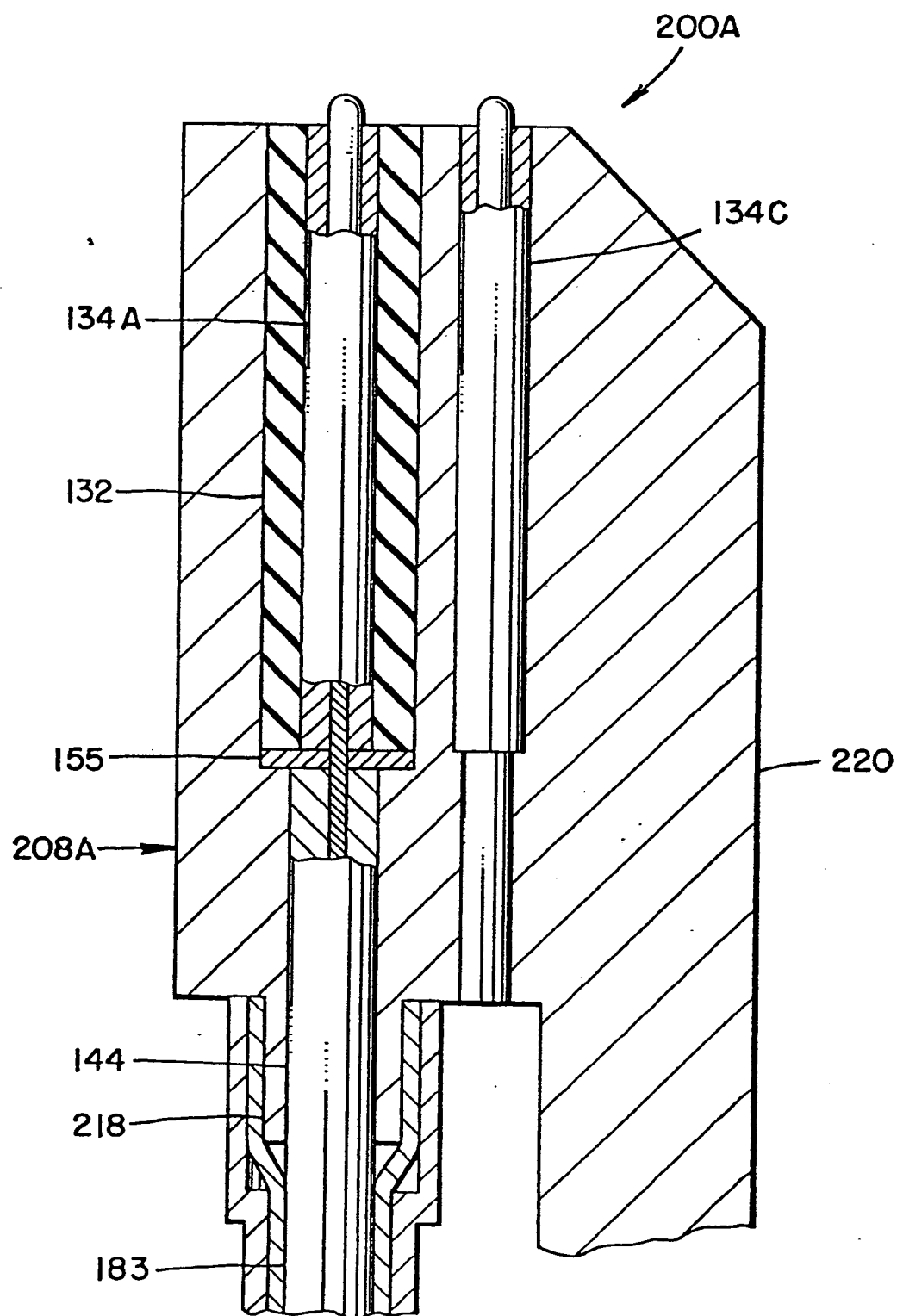
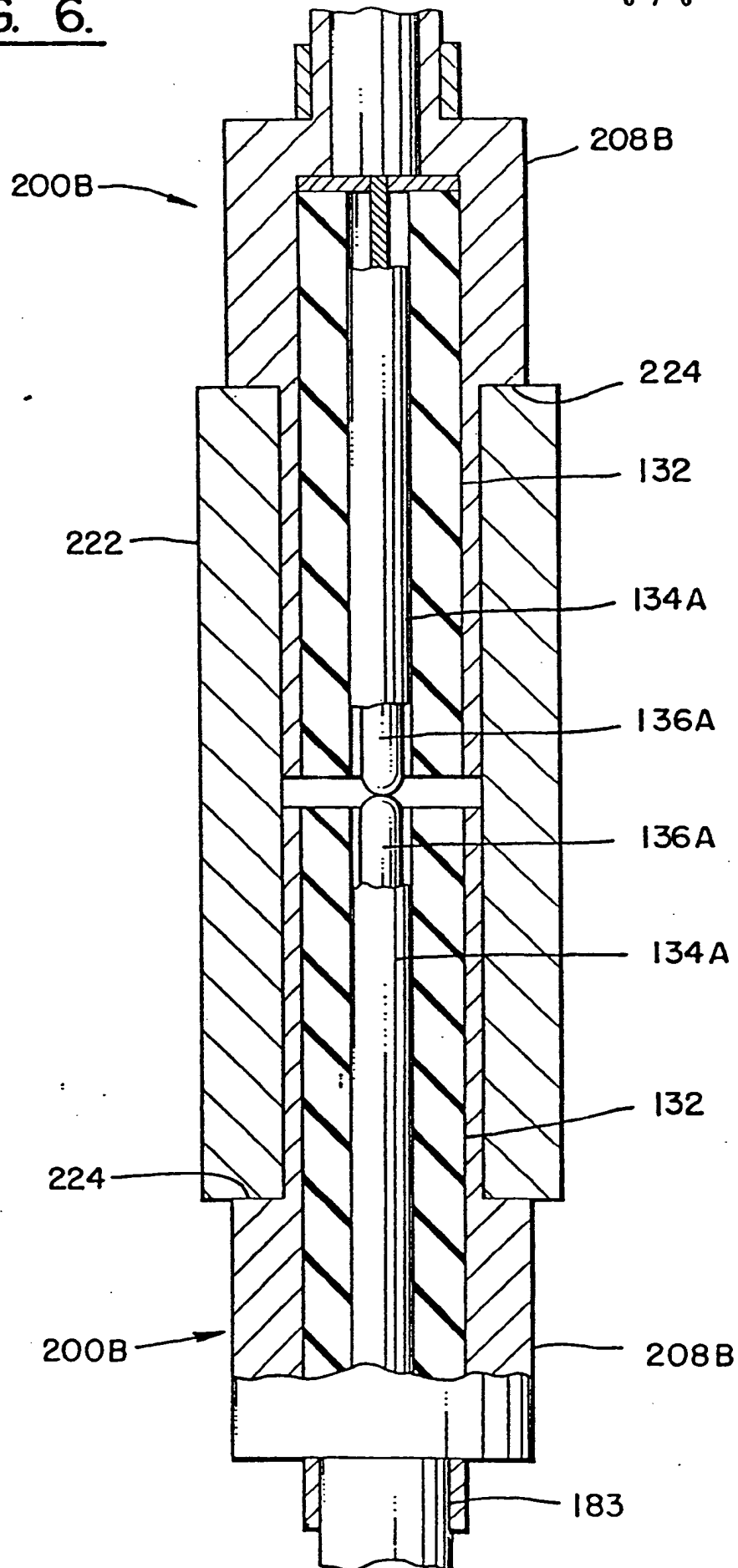
FIG. 5.

FIG. 6.





European Patent  
Office

# EUROPEAN SEARCH REPORT

0177809  
Application number

EP 85 11 1749

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Cl. 4)
A	IBM TECHNICAL DISCLOSURE BULLETIN, vol. 18, no. 3, August 1975, pages 749-750, New York, US; R.M. MORTON et al.: "High-performance AC chip contactor" * Figure 1 *	1	G 01 R 1/073 H 01 R 17/12
A	IBM TECHNICAL DISCLOSURE BULLETIN, vol. 20, no. 11B, April 1978, pages 4797-4798, New York, US; E. VALENTINE et al.: "Conductive epoxy encapsulated wafer probe" * Pages 4797-4798 *	1,9	
A	DE-A-1 465 241 (AMP INC.) * Figures 1-5 *	3	
			TECHNICAL FIELDS SEARCHED (Int. Cl. 4)
			G 01 R H 01 R
The present search report has been drawn up for all claims			
Place of search THE HAGUE		Date of completion of the search 16-01-1986	Examiner KUSCHBERT D.E.
<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons &amp; : member of the same patent family, corresponding document</p>			

**THIS PAGE BLANK (USPTO)**